

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Inventor : Yasushi HAYASHIDA, et al. CONF. NO.: 4274  
U.S. Serial No. : 10/551,225  
Group Art Unit : 3651  
Filed : September 28, 2005  
Examiner : Ramya G. Prakasam  
For : **SUBSTRATED PROCESSING SYSTEM, AND METHOD OF  
CONTROL THEREFOR, CONTROL PROGRAM, AND  
STORAGE MEDIUM**

**AMENDMENT PURSUANT TO RULE 116**

**MAILSTOP: AF**  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

In response to the Final Office Action mailed October 14, 2009, to which a response is due January 14, 2010, please amend the above-identified application as set forth below and consider the following remarks.

**Amendments to the Claims** begin on page 2.

**Remarks** begin on page 4.